

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/730,080	TAKEGAWA, AKITO
	Examiner	Art Unit
	Shih-yung Hsieh	2837

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
84	327		
	421		
	422.3		
	422.2		
224	1265	SNR	4/29/05